

# 7<sup>th</sup> Workshop 2010 Asphere Metrology



Kompetenzzentrum  
Ultrapräzise  
Oberflächen-  
bearbeitung e.V.

## **DRAFT AGENDA:**

as of Friday, October 29<sup>th</sup> 2010

### **Wednesday, December 8<sup>th</sup> / Evening**

**18.30** Get Together / Restaurant Al Duomo

### **Thursday, December 9<sup>th</sup>**

#### **Morning**

Chairman: M. Schulz; PTB; Germany

**8.30 Opening**

F. Löffler; CC UPOB e.V.; Germany

**8.45 Overview / Summary Measurements last HLEM – The story so far**

K. F. Beckstette; Carl Zeiss Jena GmbH; Germany

**9.30 Measurement of Aspheres and Freeform surfaces with the Tilted-Wave Interferometer**

E. Garbusi; ITO Uni-Stuttgart; Germany

**10.15 Coffee Break**

**10.45 Standardisation in precision optics**

E. Leitner; DIN Deutsches Institut für Normung e.V.; Germany

**11.30 New measurements of aspherical surfaces using 3D-deflectometry**

I. Mahns; TRIOPTICS GmbH; Germany

**12.15 Lunch Break**

#### **Afternoon**

Chairman: J.-M. Asfour; Dioptic GmbH; Germany

**13.30 Asphere and freeform surface measurements with the NANOMEFOS non-contact measurement machine**

R. Henselmans / G. Gubbels; TNO Science & Industry; Netherlands

**14.15 Orthogonality enables the characterisation of increasingly complex aspheres**

P. Murphy / J. P. Lormeau; QED Technologies Inc.; USA

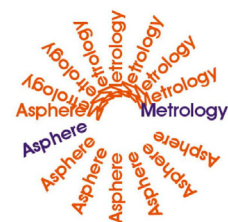
**15.00 Coffee Break**

**15.20 Final discussion**

J.-M. Asfour; Dioptic GmbH; Germany

**16.20 Outlook / Closing**

**16.30 End**



**2010**

**Workshop Asphere Metrology  
December 9<sup>th</sup> 2010**

**Workshop**

**www.upob.de**